


FORM 1449*  INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary)	Docket Number: 10873.767USWO	Application Number: 09/913,430
	Applicant: UNO et al.	
	Filing Date: 14 August 2001	Group Art Unit: 2655

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
<i>QZ</i>	EP 1 028 421	16 Aug. 2000	EPO			✓	
<i>QZ</i>	WO 99/59143	18 Nov. 1999	WIPO			✓	
<i>QZ</i>	EP 0 957 477	17 Nov. 1999	EPO			✓	
<i>QZ</i>	EP 1 005 036	31 May 2000	EPO			✓	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
		YAO et al. "Optical Transition of Chalcogenide Phase-Change Thin Films". <i>Japanese Journal of Applied Physics</i> , Vol. 42, No. 2B, pp. 828-831 (2003).

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EXAMINER <i>Jim D. G. L.</i>	DATE CONSIDERED <i>7/22/05</i>
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.	